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BIB DATA SHEET

CONFIRMATION NO. 6303

10/798,482 DATE 03/12/2004 257	2892		INO.	ATTORNEY DOCKET	
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RULE					
APPLICANTS Akira Takahashi, Tokyo, JAPAN;					
** CONTINUING DATA **********************************					
** FOREIGN APPLICATIONS ************************************					
** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 05/26/2004					
35 USC 119(a-d) conditions met Yes □ No □ Met after Allowance □ COUNTRY □ D	SHEETS DRAWINGS	TOTA CLAIN			
Verified and /WILLIAM F KRAIG/ Acknowledged Examiner's Signature Initials JAPAN	3	5	2		
ADDRESS			•		
RABIN & BERDO, P.C. Suite 500 1101 14th Street Washington, DC 20005 UNITED STATES					
TITLE					
Dry etching method for semiconductor device					
	☐ All Fee	☐ All Fees			
FFFC: Authority has been given in Dancy	□ 1.16 F	☐ 1.16 Fees (Filing)			
FILING FEE RECEIVED FEES: Authority has been given in Paper No to charge/credit DEPOSIT ACCOUNT	T □ 1.17 F	☐ 1.17 Fees (Processing Ext. of time)			
770 No for following:		☐ 1.18 Fees (Issue)			
□ Other					
	☐ Credit				